

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiromichi Ohta, et al.

Application Serial No:
09/615,883

Filed July 14, 2000

TITLE: LOW-RESISTANCE ITO
THIN FILM AND METHOD FOR
MANUFACTURING SUCH A FILM

) Before the Examiner

) Jennifer C. McNeil

) Group Art Unit 1775

) October 18, 2002

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on:

October 18, 2002
(Date of Deposit)

Charles P. Schmal
Name of Registered Representative

Charles P. Schmal
Signature

October 18, 2002
Date of Signature

In response to the Office Action dated May 20, 2002 please enter the following amendments and consider the accompanying remarks. Filed concurrent with this Amendment is a Request for a two-month Extension of Time to respond this Office Action and a Supplemental Information Disclosure Statement. Additionally, please charge any fees that may be due to Deposit Account No. 23-3030, but do not include any payment of issue fees that are or may become due.

IN THE CLAIMS

Please cancel Claims 17 ~~13~~ without prejudice or disclaimer of the subject matter therein.